

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Hiroshi IKEDA et al

GROUP ART UNIT: 1754 .

SERIAL NO:

09/463,961

**EXAMINER:** 

Timothy VANOY

PECEIVED TO 1700

FILED:

May 25, 2000

FOR:

PROCESS AND APPARATUS FOR TREATING

SEMICONDUCTOR PRODUCTION EXHAUST GASES

## NOTICE OF APPEAL

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Applicants hereby appeal to the Board of Appeals from the decision dated May 5, 2003.

The items checked below are appropriate:

- months. ☐ A Petition for Extension of Time Under 37 C.F.R. §1.136 was filed for
- ☐ A timely response to the final rejection has been filed, as provided in 841 O.G. 1411.
- A Petition for Extension of Time for filing the Notice of Appeal is attached.

Fee: \$320.00

- ☐ Applicant claims small entity status. See 37 CFR 1.27.
- ☐ A check is enclosed
- A credit card payment form is enclosed
- ☐ Charge to Deposit Account No. <u>15-0030</u> (an additional copy of this notice is enclosed herewith).
- Please charge any additional fees or credit any overpayment of fees required for filing the Notice of Appeal to Deposit Account No. 15-0030. A duplicate copy of this Notice is enclosed.
- If this notice is not considered timely filed by the U.S. Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this Notice is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

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